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Technology and Culture (ISSN 0040-165X) is published four times a year, January, April, July, and October, by The University of Chicago Press. Subscriptions: institutions, \$54.00; individuals, \$27.50. Student rate: 1 year \$19.00 (photocopy of valid student I.D. must accompany subscription). Emeritus: 1 year \$23.00. Add \$4.50/year postage for subscriptions mailed outside the U.S.A. and its possessions. Subscription agent for Japan: Kinokuniya Company, Ltd. Single copies: institutions \$13.50, individuals \$7.00. Back issues are available from 1984 (vol. 25). Subscriptions include membership in the Society for the History of Technology. Checks should be made payable to The University of Chicago Press, Journals Division, P.O. Box 37005, Chicago, Illinois 60637; all business correspondence, including changes of address (old as well as new address), should be sent to that address.

Volumes 1–24 available from Kraus Reprints, Route 100, Millwood, New York 10546. All volumes are available in microfilm from University Microfilms, 300 North Zeeb Road, Ann Arbor, Michigan 48106; in microfiche from KTO Microform, Route 100, Millwood, New York 10546.

Editorial correspondence, manuscripts, and books for review should be sent to Dr. Robert C. Post, National Museum of American History, Room 5030, Smithsonian Institution, Washington, D.C. 20560. Further instructions on submissions follow the table of contents.

Editorial office sponsored by National Museum of American History, Roger G. Kennedy, director.

Published by The University of Chicago Press, Chicago, Illinois 60637; The University of Chicago Press Ltd., London W.C. 1. Second-class postage for *Technology and Culture* paid at Chicago.

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The paper used in this publication meets the minimum requirements of American National Standard for Information Sciences—Permanence of Paper for Printed Library Materials, ANSI Z39.48–1984. (2)